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DOCKET NO: VSEA 05-99

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.
Serial No: 09/602,059
Confirmation No: 9493
Filed: June 23, 2000
For: ION IMPLANTER HAVING TWO-STAGE DECLERATION
BEAMLINE
Examiner: Mary A. El-Shammaa
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the 6th day of May, 2003.

Cheryl A. Purcell
Cheryl Purcell

Commissioner for Patents
Washington, D.C. 20231

Sir:

Petition for Extension of Time

A three-month extension of time to May 6, 2003 is requested for response to the Examiner's Office Action of November 6, 2002.

The extension fee of \$930.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

05/12/2003 CNGUYEN 00000135 500896 09602059
01 FC:1253 930.00 CH

Respectfully submitted,
Charles M. McKenna et al., Applicants

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